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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10002177	FILING DATE 12/05/2001	CLASS 425	SUBCLASS 730	GAU 1723	EXAMINER Kackar
<b>**APPLICANTS:</b> Komeno Junji; Shiina Kazushige;					
<b>**CONTINUING DATA VERIFIED:</b>					
<b>BEST AVAILABLE COPY</b>					
<b>** FOREIGN APPLICATIONS VERIFIED:</b> JAFAN 2000-373278 12/07/2000					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO Q67579	
Verified and Acknowledged Examiners's initials					
TITLE : Film-forming device with a substrate rotating mechanism					
U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L Rev. 12-94					

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Assistant Examiner	
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Total Claims	
		Print Claim for O.G.	
		Sheets Drwg. Figs.Drwg. Print Fig.	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Primary Examiner	
		Application Examiner	
		<b>PREPARED FOR ISSUE</b>	
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